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<td>Author(s)</td>
<td>Chen, XD; Ling, CC; Gong, M; Fung, S; Beling, CD; Brauer, G; Anwand, W; Skorupa, W</td>
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Anomalous behaviors of $E_1/E_2$ deep level defects in 6H silicon carbide

X. D. Chen and C. C. Ling
Department of Physics, The University of Hong Kong, Pokfulam Road, Hong Kong, People's Republic of China

M. Gong
Department of Physics, Sichuan University, Chengdu, People's Republic of China

S. Fung and C. D. Beling
Department of Physics, The University of Hong Kong, Pokfulam Road, Hong Kong, People's Republic of China

G. Brauer, W. Anwand, and W. Skorupa
Institut für Ionenstrahlphysik und Materialforschung, Forschungszentrum Rossendorf, Postfach 510119, D-01314 Dresden, Germany

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Deep level defects $E_1/E_2$ were observed in He-implanted, 0.3 and 1.7 MeV electron-irradiated n-type 6H–SiC. Similar to others’ results, the behaviors of $E_1$ and $E_2$ (like the peak intensity ratio, the annealing behaviors or the introduction rates) often varied from sample to sample. This anomalous result is not expected of $E_1/E_2$ being usually considered arising from the same defect located at the cubic and hexagonal sites respectively. The present study shows that this anomaly is due to another DLTS peak overlapping with the $E_1/E_2$. The activation energy and the capture cross section of this defect are $E_C$−0.31 eV and $\sigma \sim 8 \times 10^{-14}$ cm$^2$, respectively. © 2005 American Institute of Physics. [DOI: 10.1063/1.1853523]

Silicon carbide (SiC) is a wide band-gap semiconductor material having physical and electronic properties suitable for high-temperature, high-power, and high-frequency electronic applications. Deep level defects induced by ion implantation or particle irradiation in SiC have been extensively studied by capacitance transient techniques such as deep level transient spectroscopy (DLTS).\textsuperscript{2–11} Deep levels $E_1/E_2$ ($E_C$−0.34 eV/0.44 eV) are dominant levels observed in electron-irradiated n-type 6H–SiC\textsuperscript{3,6,8,10} (known as $Z_1/Z_2$ in 4H–SiC). However, their intensities are relatively low in neutron irradiated or He implanted samples.\textsuperscript{2–5,9} $E_1/E_2$ are usually considered to be the same defect but residing at the hexagonal ($h$) and the cubic ($k_1, k_2$) sites, respectively. This implies that their physical behaviors such as the peak intensity ratio, introduction rates and annealing behaviors, should be independent of sample. However, observations have indicated otherwise.\textsuperscript{4,5} To investigate this anomaly, we have performed DLTS and annealing studies on He-implanted and electron-irradiated (with energies $E_e=0.2$, 0.3, and 1.7 MeV) 6H–SiC.

The starting n-type materials were 5-μm-nitrogen doped (0001) epitaxial layer ($n=1 \times 10^{16}$ cm$^{-3}$) grown on n$^+$-type 6H–SiC substrate ($n=8 \times 10^{17}$ cm$^{-3}$) purchased from Cree Inc. Details of sample preparation, Ohmic and Schottky contacts fabrication were reported in Ref. 9. Samples were implanted with He ions and irradiated with electrons to create the $E_1/E_2$ defects. He ions with energies of 55, 210, 430, 665, and 840 keV (each with fluence of $\sim 2 \times 10^{11}$ cm$^{-2}$) were implanted into the sample so as to produce a 2-μm deep box-shape implanted layer. Electron irradiation was carried out with electrons energies of 1.7, 0.3, and 0.2 MeV (dosage $5 \times 10^{15}$ cm$^{-2}$). Isochronal annealing from 100 to 1200 °C was carried out in the Ar gas atmosphere for 30 min. The quality of all the Schottky-diode-like samples were monitored by observing $I–V$ and $C–V$ characteristics. DLTS was carried out at 100–400 K.

Figure 1 shows DLTS spectra of the He-implanted, electron-irradiated ($E_e=0.3$ and 1.7 MeV) samples with different annealing treatments. The $E_1/E_2$ peaks (at $\sim 200$ K) were the dominant peaks in the as-electron-irradiated samples. However, these were not detected in the 0.2 MeV electron-irradiated sample.\textsuperscript{10} Moreover, these peaks from the as-1.7-MeV-irradiated sample shift to the low temperature side and the line shape was also broadened as compared to the 0.3 MeV sample.\textsuperscript{10} However, with annealing above 300 °C, these peaks for the 1.7 MeV sample become narrower and the position shift to the high temperature side\textsuperscript{10}

![Figure 1. DLTS spectra for the He-implanted, 1.7 and 0.3 MeV electron-irradiated samples with different annealing conditions. A rate window of 6.82 ms was used in the measurements.](image)

\textsuperscript{a}Electronic mail: ccling@hku.hk
(see the 700 °C annealed 1.7 MeV electron-irradiated spectrum in Fig. 1). This observation is ascribed to the presence of another deep level peak ED2 on the low temperature side of the E1. ED2 was only introduced with $E_e > 0.5$ MeV and is annealed out at 300 °C.\(^\text{10}\) In contrast, the $E_1/E_2$ signal was very weak in the as-He-implanted sample and strengthened for the 1.7-MeV-irradiated and the He-implanted samples, different for these samples. Different $E_1/E_2$ ratios should thus be fixed and annealing behavior similar. For $E_1/E_2 = 2–6$, the $E_1$ signal was clearly seen in the DLTS spectrum of the 900 °C He implanted sample with $V_{pp} = -2 \text{ V}$, rate window = 136 ms and $t_p = 100 \mu \text{s}$. Here the proposed defect peak is clearly separated from the $E_1$ peak. This peak can be observed with the rate window=136 ms but not in the spectra in Fig. 1 (rate window=100 ms). The anomaly was also observed in the as-He implanted samples. Moreover, the anomalies in the He implanted and the 1.7 MeV $e^+$-irradiated samples disappear after annealing at about 1000 °C.

First, we can conclude that the anomalies are not associated with ED2 which overlaps with the $E_1/E_2$ peaks because the ED2 has already annealed out at 300 °C. Moreover, these anomalies were not observed in the low energy irradiated (0.3 MeV) samples or after 1000 °C annealing. One plausible explanation for such observations is the presence of an extra DLTS peak which overlaps with the $E_1/E_2$ peaks. This defect, which anneals out at about 1000 °C, is induced by He implantation or with electron irradiation with energy as high as 1.7 MeV. This implies that the $E_1/E_2$ peaks observed in the low energy electron-irradiated (0.3 MeV) sample, the 1.7 MeV irradiated and the He-implanted samples after the 1000 °C annealing are the “pure” $E_1/E_2$ peaks. From all these spectra which contain the “pure” $E_1/E_2$ peaks, $\sigma(E_1) \sim \sigma(E_2) \sim 5 \times 10^{-15} \text{ cm}^2$ and $E_1/E_2$ ratio is $\sim 0.5$. As the $E_1$ signal observed in the He implanted and the 1.7 MeV electron irradiated samples annealed at temperatures below 1000 °C is contributed from the pure $E_1$ and the proposed extra defect, the different annealing behaviors of the $E_1$ and $E_2$ peak intensities as seen in Figs. 1 and 2, and also the anomalous log plot shown in Fig. 3 can thus be understood.

In order to test our proposed phenomena that the proposed defect peak merged with the $E_1/E_2$ signals and were too close to be well separated (as shown in Fig. 1), we have attempted to resolved the proposed peak and the $E_1/E_2$ by changing the spectrometer’s settings (i.e., $V_{pp}$, rate window and $t_p$) as varying these settings would change the peaks positions and intensities, and the extent of change would vary from defect to defect. Figure 4 shows the most convincing evidence for our proposal, in which the proposed peak was clearly seen in the DLTS spectrum of the 900 °C He implanted sample with $V_{pp} = -2 \text{ V}$, rate window = 136 ms and $t_p = 100 \mu \text{s}$. Here the proposed defect peak is clearly separated from the $E_1$ peak. This peak can be observed with the rate window=136 ms but not in the spectra in Fig. 1 (rate window=100 ms).
window= 6.82 ms) because increasing the rate window shifts the peaks to low temperature and this peak moves with a faster pace. With the Arrhenius plot, the activation energy and the cross section of this deep level were, respectively, found to be $E_C = -0.31$ eV and $8 \times 10^{-14}$ cm$^2$. It is also worth pointing out that great care should always be taken while studying the annealing behavior of $E_1/E_2$, as the annealing of this defect at about 1000 °C could be misinterpreted as the drop of the $E_1/E_2$ intensity. The exact detail of this defect’s microstructure is not known as DLTS does not offer direct information about the defect’s microstructure. It was reported that the defect induced by the 0.3 MeV electron irradiation should be a primary defect involving the displacement of the C-atom in the SiC lattice [10] (i.e., isolated $V_{C_i}$, $C_i$, or $V_{C-C_i}$). The $E_C = -0.31$ eV defect should not be related to these primary defects because it was not detected in the 0.3 MeV electron irradiated sample.

In conclusion, this work has revealed a new defect which exists in He implanted and high energy electron-irradiated samples and anneals out at about 1000 °C. This discovery accounts for the discrepancy with the intensity ratio and capture cross sections expected of $E_1/E_2$ being from the same defect at different equivalent sites.

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